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ISSUE DATE
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U.S. UTILITY Patent Application

APPL NUM 10032930	FILING DATE 10/29/2001	CLASS 257	SUBCLASS 622	GAU 2811	EXAMINER D. LE
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257 758

**CONTINUING DATA VERIFIED: *N/A*
DL

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** FOREIGN APPLICATIONS VERIFIED: *N/A*
DL

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO 072219-0278259 (P05108)
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials		<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	
TITLE : Apparatus and method for reducing surface zener drift using Ti-based metallurgy U.S. DEPT. OF COMM./PAT. & TM-PTO-438L (Rev. 12-94) <i>35 Semiconductor structure for reducing surface zener drift using titanium-based metallurgy</i>			

NOTICE FALLOWANCE MAILED

11/23/03

Assistant Examiner

CLAIMS ALLOWED

Total Claims

15

Print Claim for
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